I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to the Assistant Commissioner for Patents, Washington, D.C. 20231

By: White

Date: Fcb. 7, 2003

AN VIUS 812763

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor : Matthias Förster et al.

Applic. No.: 09/901,526

Filed : July 9, 2001

Title : Process for Producing a Microroughness on a

Surface

Examiner : Savitri Mulpuri Art Unit: 2812

## AMENDMENT

Hon. Commissioner of Patents and Trademarks, Washington, D. C. 20231

## Sir:

Responsive to the Office action dated November 7, 2002 kindly amend the above-identified application as follows:

## In the Claims:

Cancel claims 1-11.

FEBIL 2003 FEBIL 2003